

<b>Notice of References Cited</b>	Application/Control No. 10/580,177	Applicant(s)/Patent Under Reexamination KUWAMURA, HIROSHI	
	Examiner HUNG NGUYEN	Art Unit 3742	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,429,114 A	07-1995	Taplan et al.	126/211
*	B	US-5,640,947 A	06-1997	Shute, Alan B.	126/211
*	C	US-5,893,359 A	04-1999	Schultheis et al.	126/214A
*	D	US-6,175,102 B1	01-2001	Stedron et al.	219/452.11
*	E	US-6,207,934 B1	03-2001	Steiner et al.	219/452.11
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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